

EAST Search History

EAST Search History (Interference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	6	((semiconductor or substrate or wafer) AND (wash\$4 or clean \$4 or decontaminat\$4 or rins\$4 or etch\$4) AND (acid or etchant or water or liquid or solution) AND (DRY\$4 OR DRIER) AND (ATMOSPHERE OR OUTSIDE OR ENVIRONMENT) AND (CARRIER OR TRANSPORTER OR HOIST OR LIFTER) AND (GAS OR NITROGEN) AND (PURG\$4 OR FLUSH\$4)).CLM.	US-PGPUB	OR	ON	2010/07/19 10:52

7/ 19/ 10 10:53:17 AM